						Docket Number (Optional)		Application Number 09/031,617		
		RMATION		RE CITATION		Applicant(s) Cathey, et al.				
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9P		Verhaar, et al., "A 25 um Bulk Fill CMOS SRAM Cell Technology With Fully Overlapping Contacts," IEDM Technical Digest, pp. 473-476, International Electon Devices Meeting, San Francisco, CA December 9-12, 1990.								
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